

PATENT

Docket No. 29273/502

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ASSISTANT COMMISSIONER
FOR PATENTS
Washington, DC 20231

SIR:

Transmitted herewith for filing under 37 C.F.R. § 1.53 is the patent application of

Inventors : Hajime KAWANO et al.
Serial No. : (Unassigned)
Filed : (Herewith)
For : ELECTRON BEAM LITHOGRAPHY SYSTEM

Enclosed are:

1. Declaration/Power of Attorney;
2. 35 sheets of specification, 4 sheets of claims, 1 sheet of abstract;
3. 14 sheets of drawings;
4. Charge Deposit Account No. 11-0600 in the amount of \$760.00 representing the fee under 37 C.F.R. §§ 1.16(a), (b) and (c);
5. Certified Copy of Japanese Patent Application No. 10-149045 filed in Japan on 29 May, 1998, for which priority is claimed under 35 USC §119;
6. Information Disclosure Statement, form PTO-1449 with 12 references;
7. Assignment from the Inventors to Hitachi, Ltd., Tokyo, Japan, with recordation form cover sheet charging the fee to Deposit Account No. 11-0600.

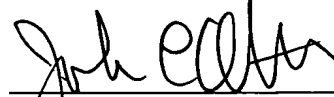
The filing fee has been calculated as shown below:

For	No. Filed	No. Extra	Rate	Fee
Basic Fee				\$760.00
Total Claims	10 - 20 =	0	\$ 18.00	\$ -0-
Independent Claims ..	2 - 3 =	0	\$ 78.00	\$ -0-
TOTAL FEE				<u>\$760.00</u>

The Commissioner is hereby authorized to charge payment of the total fee of \$760.00 and any additional fees associated with this communication or credit any overpayment to Deposit Account No. 11-0600.

The Commissioner is further authorized to charge payment of any patent application processing fees under 37 C.F.R. §1.17 or any filing fees under 37 C.F.R. §1.16 for presentation of extra claims during the pendency of this application or credit any overpayment to Deposit Account No. 11-0600. A copy of this sheet is enclosed for that purpose.

Respectfully submitted,



John C. Altmiller
(Reg. No. 25,951)

Dated: 21 May 1999

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